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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): Ralph C. Struthers; David B. Chang; Reza Toossi; Sion Ahdout; Lijuan Li; Robert G. Palomba  
Assignee: EnerNext, LCC  
Title: Method for Sorption and Desorption of Molecular Gas Contained by Storage Sites of Nano-Filament Laded Reticulated Aerogel (As Amended)  
Serial No.: 10/666,663 Filing Date: September 18, 2003  
Examiner: Ling Siu Choi Group Art Unit: 1713  
Docket No.: M-15154US Confirmation No.: 8992

Irvine, California  
December 14, 2004

**Via Facsimile to (703) 872-9306**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**PETITION FOR EXTENSION OF TIME**

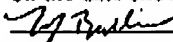
Dear Sir:

Applicants respectfully petition for a three (3)-month extension of time within which to respond to the First Office Action mailed July 1, 2004, such extension allowing the undersigned until January 1, 2005 to respond.

Please charge the amount of \$510.00 (for a small entity) as set forth in the accompanying Transmittal.

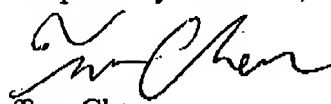
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I hereby certify that this paper is being facsimile transmitted to the U.S. Patent and Trademark Office on the date shown below.

  
Montique M. Butler

December 14, 2004  
Date of Signature

Respectfully submitted,

  
Tom Chen  
Attorney for Applicants  
Reg. No. 42,406

LAW OFFICES OF  
MacPHERSON KWOK  
CHEN & WONG LLP

1762 Technology Drive  
Suite 226  
San Jose, CA 95110  
(949) 752-7040  
FAX (408) 392-9262